

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/001,495	LI ET AL.	
Examiner	Art Unit	
Richard H. Kim	2871	

	SEARCHED					
Class	Subclass	Date	Examiner			
	:					
			-			
			••••			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
<u> </u>	1_			

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
East Text Search (349/113; Jpo, epo, uspat, pgpub)-see printout	9/15/2005	RHK
•		
·		